



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS  
UNITED STATES PATENT AND TRADEMARK OFFICE  
P.O. Box 1450  
ALEXANDRIA, VA 22313-1450  
www.uspto.gov

MAILED

Maria S. Swiatek

Flehr Hohbach Test Albritton & Herbert LLP    AUG 31 2004  
Four Embarcadero Center, Suite 3400  
San Francisco, CA 94111-4187

DIRECTOR'S OFFICE  
TECHNOLOGY CENTER 3600

In re Application of

Richard N. Savage et al.  
Application No. 09/767,659

Filed: January 22, 2001

For: SEMICONDUCTOR WAFER PROCESSING  
SYSTEM WITH VERTICALLY-STACKED PROCESS  
CHAMBERS AND SINGLE-AXIS DUAL-WAFER TRANSFER SYSTEM

DECISION ON PETITION  
TO WITHDRAW THE  
HOLDING OF ABANDONMENT

This is in reply to the renewed petition to withdraw the holding of abandonment under 37 CFR 1.181, filed in the United States Patent and Trademark Office, on June 14, 2004.

The petition is GRANTED in view of the following evidence of timely filing:

- Postcard receipt being dated \_\_\_\_\_.
- USPTO return facsimile receipt dated \_\_\_\_\_ which identifies the application by serial number and the type of Response that was filed on that date.
- Certificate of Mailing/Transmission signed on April 29, 2003 and supported by a statement under 37 C.F.R. 1.8(b)(3).
- Hand Delivery Receipt of the specific documents submitted dated \_\_\_\_\_.
- Certificate of Transmission of CPA under 37 C.F.R. 1.6 filed on \_\_\_\_\_.
- Express Mail Receipt under 37 C.F.R. 1.10 dated \_\_\_\_\_.

This application is being forwarded to the Supervisory Legal Instruments Examiner for entry of the response filed with the petition, then to the examiner for prompt action on the response.

SNM/vdb: 8/26/04

  
STEVEN N. MEYERS  
SPECIAL PROGRAM EXAMINER  
TECHNOLOGY CENTER 3600